



IFW

PATENT  
Customer No. 22,852  
Attorney Docket No. 04329.3140

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Takashi YODA, et al. ) Group Art Unit: 2814  
)  
Application No.: 10/663,799 ) Examiner: Cao, Phat X.  
)  
Filed: September 17, 2003 )  
)  
For: SEMICONDUCTOR DEVICE AND )  
METHOD OF MANUFACTURING )  
THE SAME )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

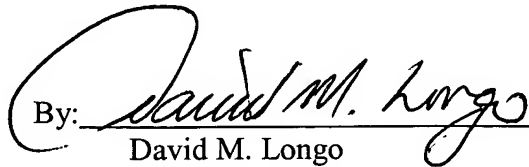
In the Restriction Requirement mailed October 12, 2004, with a period for response extending to November 12, 2004, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-6) and Group II (claims 7-20). Applicants provisionally elect to prosecute Group I, claims 1-6, characterized by the Examiner as drawn to a semiconductor device.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: November 2, 2004

By:   
David M. Longo  
Reg. No. 53,235